

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Matsui

Serial No.: 09/709,454

Filed: 11/13/2000

Title: METHOD AND APPARATUS FOR  
MECHANOCHEMICAL POLISHING



Atty. Dkt.: 01-099-RCE2

Art Unit: 3723

Examiner: Shakeri

Commissioner for Patents  
U.S. Patent and Trademark Office  
2011 South Clark Place  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Date: 20 May 2004

**AMENDMENT UNDER 37 CFR 1.111**

Sir:

In response to the office action mailed 21 November 2003 please amend the application  
as follows:

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of  
this paper.

**Remarks** begin on page 9 of this paper.

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MAY 26 2004

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